

Commissioning of AHCAL electronics in the test beam

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on behalf of the CALICE analogue HCAL group

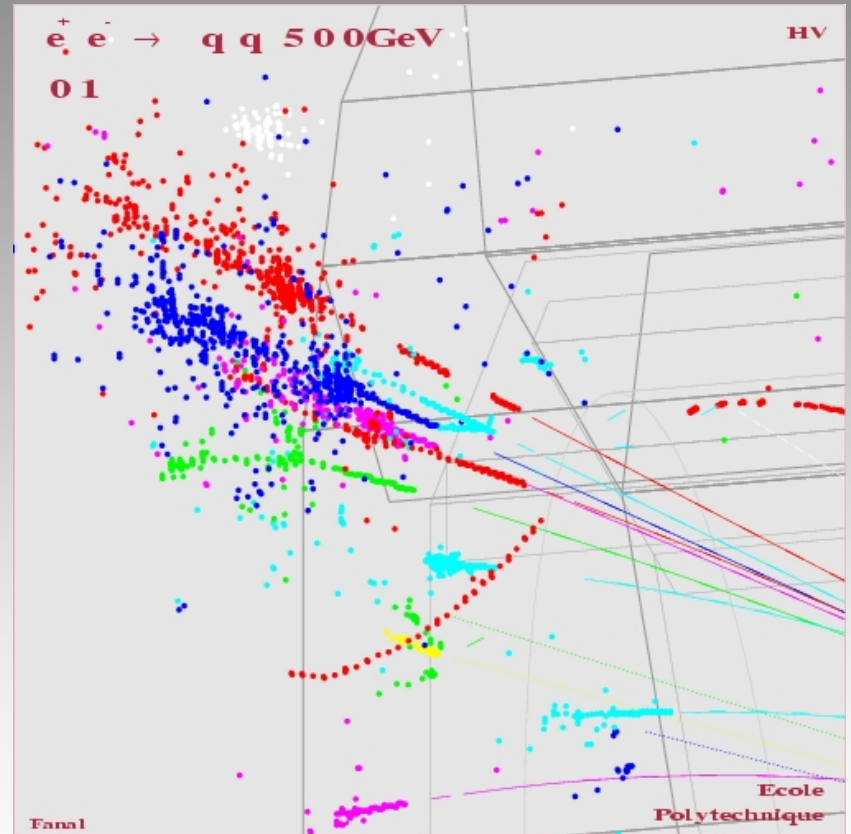
- Hadronic Calorimeter with scintillator tiles
- Innovative photodetector technology: SiPM
- VFE electronics specific for test beam data taking
- First test beam results

The internal structure of hadronic showers is not fully known

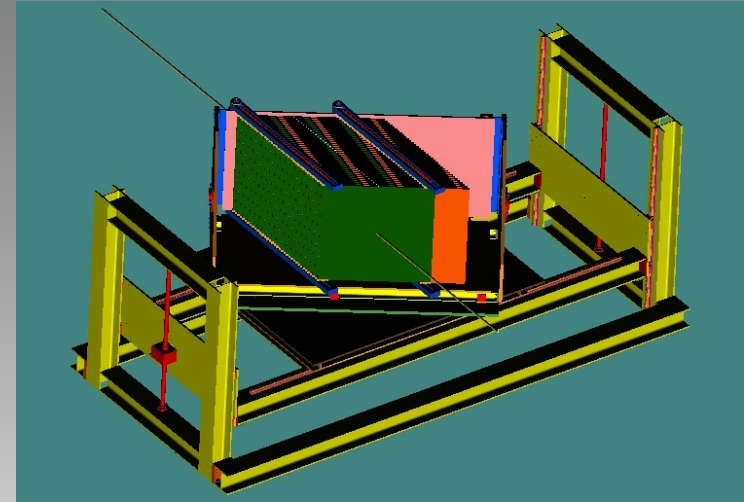
→ important issue for simulation improvement (detector studies)

→ Idea: Tracking calorimeter = **high granularity** to reconstruct single particles in the shower

→ Particle flow: optimisation of the detector performance by reconstruction of each particle individually



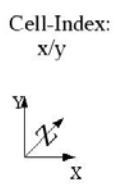
In the framework of CALICE:
 1 m³ Tile HCAL prototype ~ 8000 calorimeter tiles equipped with SiPM
 → at present under construction
 38 layers of sandwich structure with scintillator tiles + 2cm steal absorber plates



Tile Hcal Numbering Scheme I

Fine granulated layer 1-30

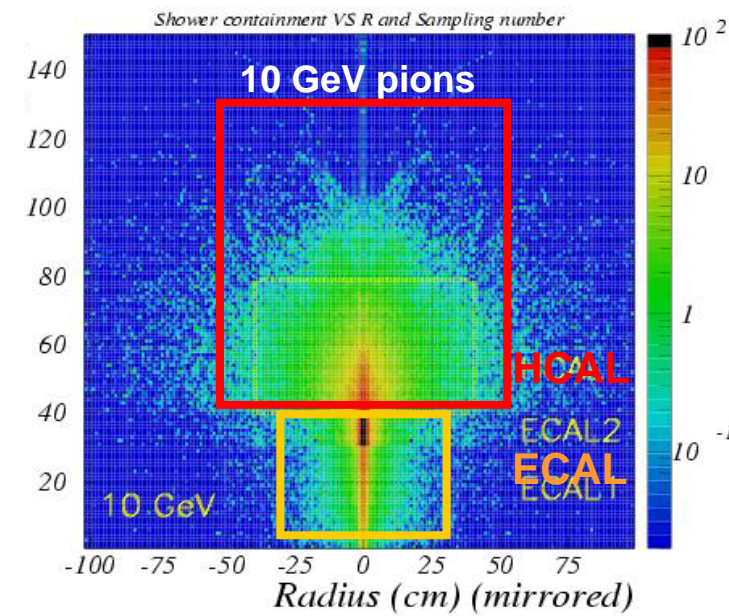
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1/67	13/73 19/73 25/73	31/73 37/73 43/73 49/73 55/73 61/73	67/73 73/73				
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1/19	13/25 19/25 25/25	31/25 37/25 43/25 49/25 55/25 61/25 67/25 73/25					
	13/19 19/19 25/19	31/19 37/19 43/19 49/19 55/19 61/19 67/19 73/19					79/13
	13/13 19/13 25/13	31/13 37/13 43/13 49/13 55/13 61/13 67/13 73/13					
	13/1	25/1	37/1	49/1	61/1		



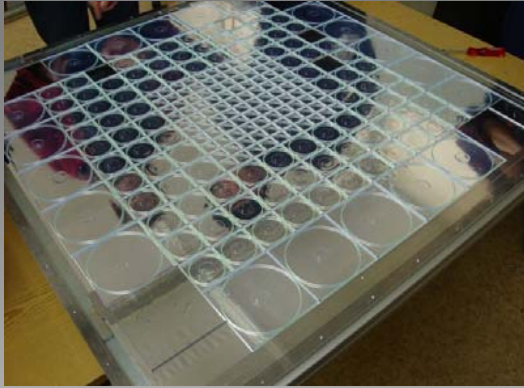
HCAL:
 High granularity
 scintillator tiles

**3x3cm² in the core
 with individual
 readout**

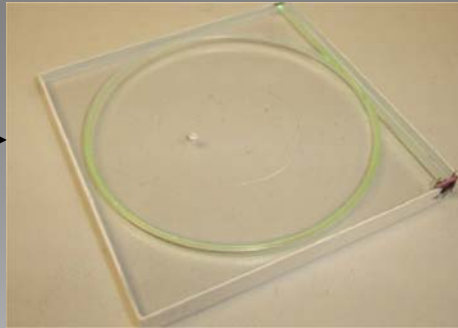
ECAL:
 Silicon-tungsten
 40 layers, 1x1cm²



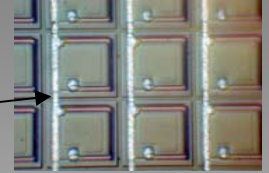
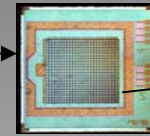
The HCAL readout chain



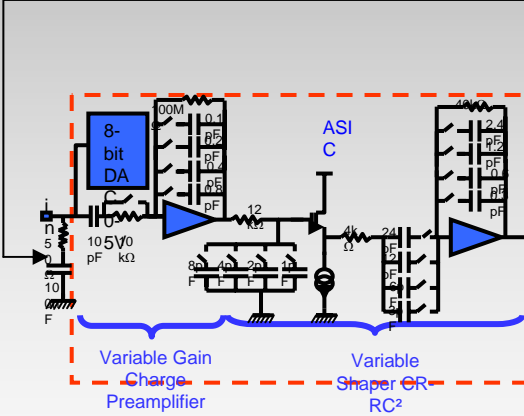
Read out 216 tiles/module
~8000 channels



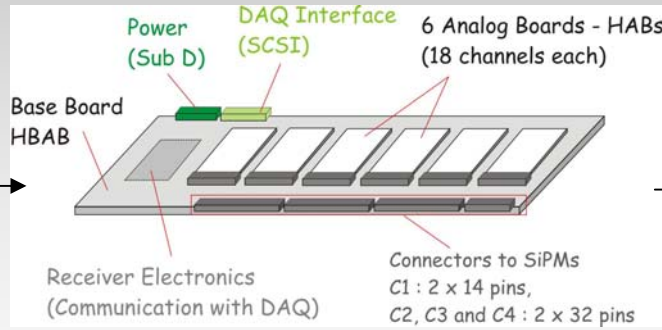
Single tile readout
with SiPM



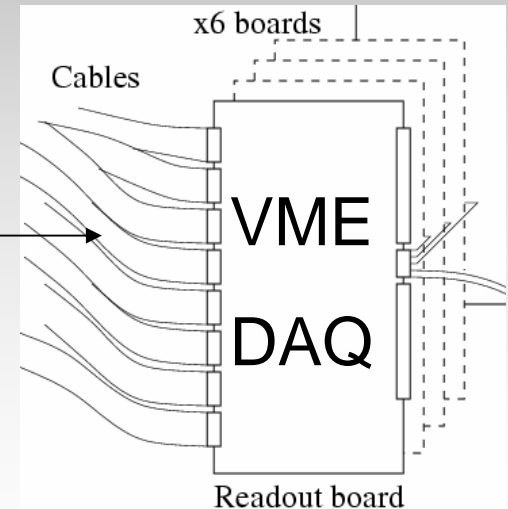
SiPM: pixel device
operated in Geiger
mode



ASIC: amplification +
shaping + multiplexing



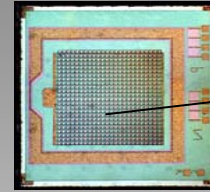
VFE: control 6 ASICs
connect to SiPM



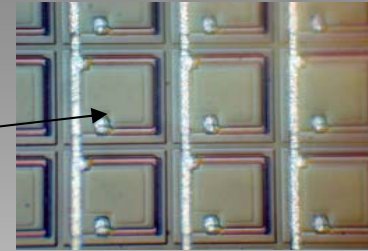
Silicon PhotoMultiplier

- Multipixel avalanche photodiode operated in geiger mode
- new detector concept, first test with beam
- sizes: $1 \times 1 \text{ mm}^2$, 1156 pixels/ mm^2
- gain $\sim 10^6$
- photon detection eff. $\sim 10\text{-}17\%$
 $= \text{Q.E.} \times \text{geiger discharge (U)} \times \text{geom. eff.}$
 $= 80\% \times 60\% \times 35\%$
- single tile read out / mounted directly on tile

Silicon PhotoMultiplier (SiPM)
MEPhi&PULSAR



SiPM



Pixels of
the SiPM

Geiger mode:

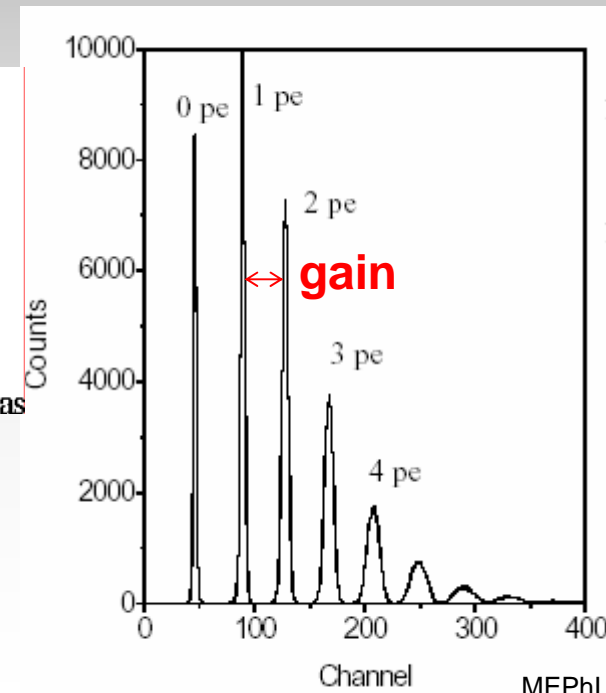
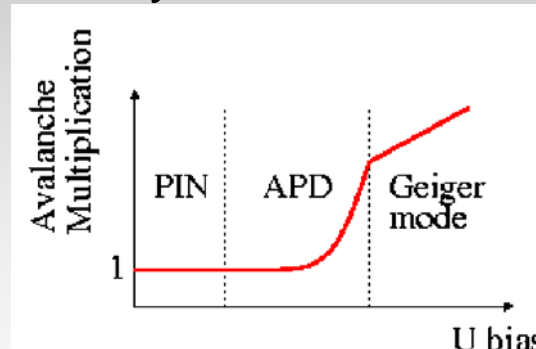
Quenching $R \sim 1 \text{ M}\Omega$

→ fast signal

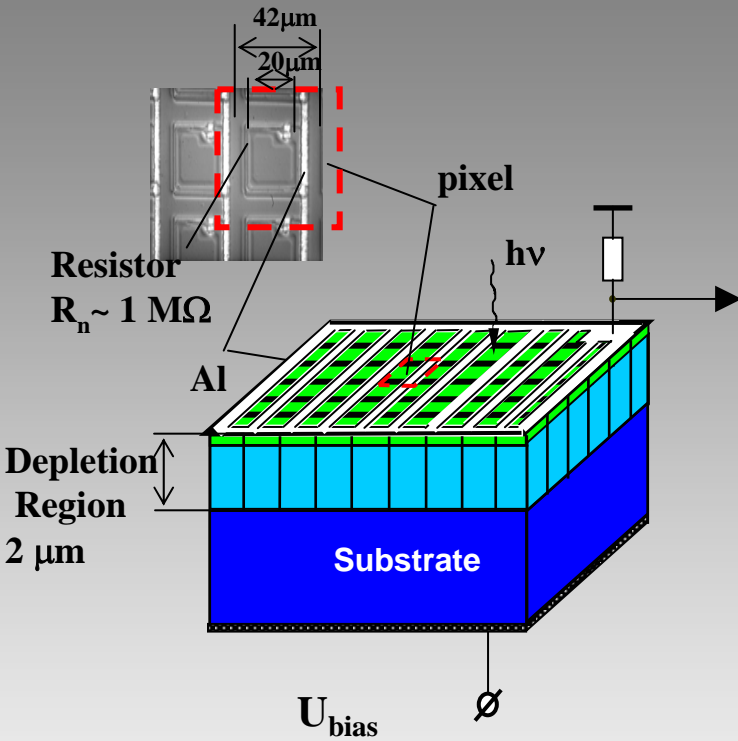
→ Proportionality to energy is lost for each pixel signal

→ Obtain back due to the high amount of pixels

→ Semi digital device



SiPM main characteristics



Working point: $V_{Bias} = V_{breakdown} + \Delta V \sim 50-60 V$

$\Delta V = 10-15\%$ above breakdown voltage

Each pixel behaves as a Geiger counter with

$$Q_{pixel} = \Delta V C_{pixel}$$

with $C_{pixel} \sim 50 \text{ fF} \rightarrow Q_{pixel} \sim 300 \text{ fC} \sim 10^6 e$

Small depletion region $\sim 2 \mu\text{m}$

\rightarrow strong electric field $(2-3) 10^5 \text{ V/cm}$

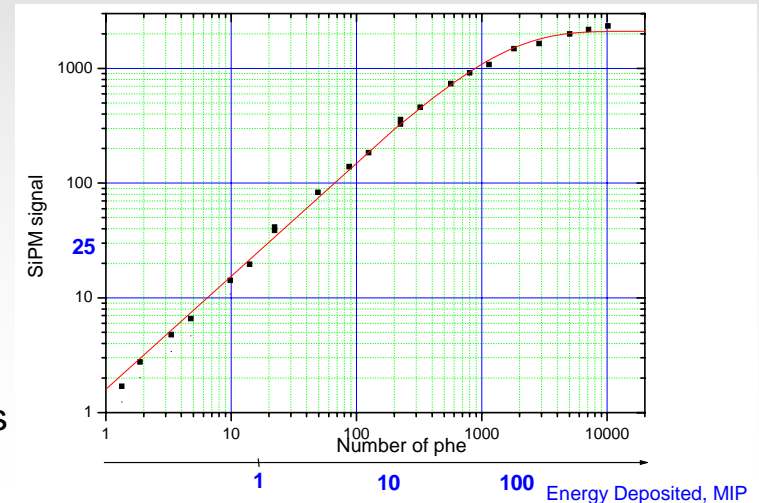
\rightarrow carrier drift velocity $\sim 10^7 \text{ cm/s}$

\rightarrow fast Geiger discharge $< 500 \text{ ps}$

\rightarrow pixel recovery time = $(C_{pixel} \times R_{pixel}) \sim 100 \text{ ns}$

Dynamic range \sim number of pixels

\rightarrow saturation



Specification for the VFE electronics

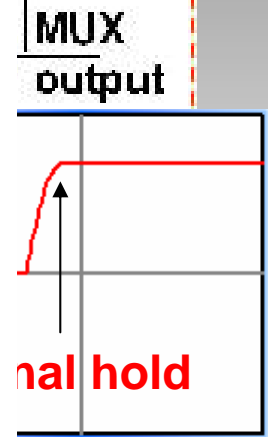
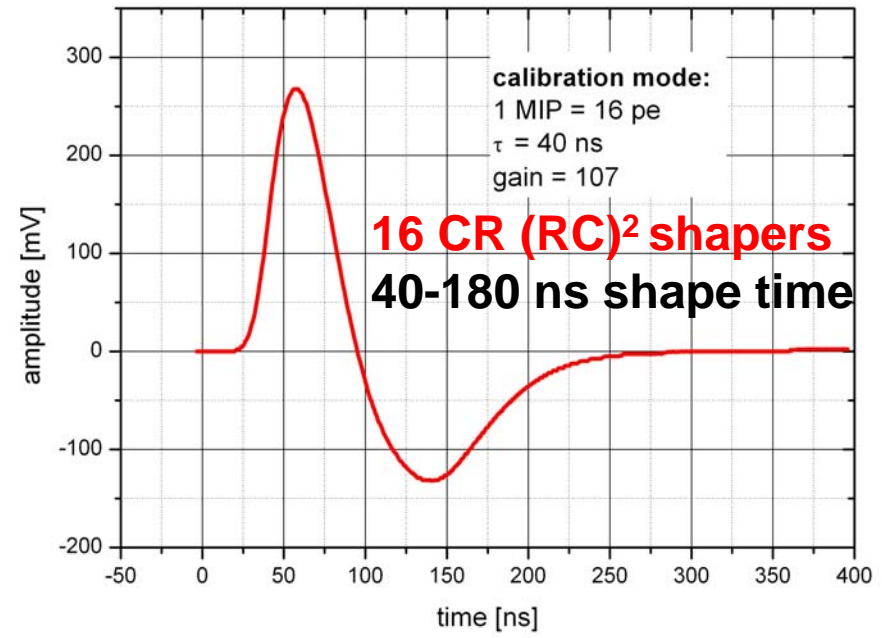
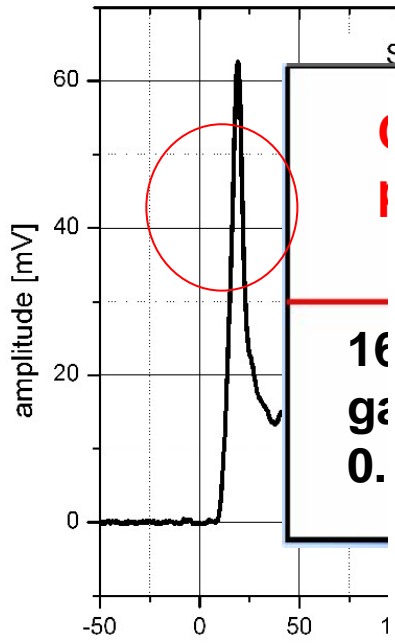
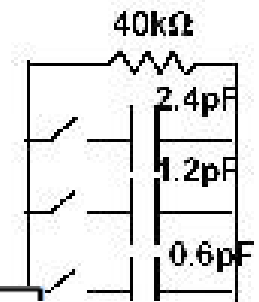
- 1) Operate 8000 SiPM with individual bias voltage adjustment
- 2) Decouple charge signal of SiPM, preamplify and multiplex it before the ADC
- 3) The HCAL prototype has to operate in a test beam setup
 - time needed for beam trigger logic ~150 ns
 - need to delay the SiPM signal to wait for the creation of the hold signal
- 4) Need to exploit the SiPM gain calibration possibility
 - minimize ASIC preamplifier noise
 - minimize noise contribution from SiPM dark rate
 - shortest possible integration time

Single channel
HV tune

8-bit

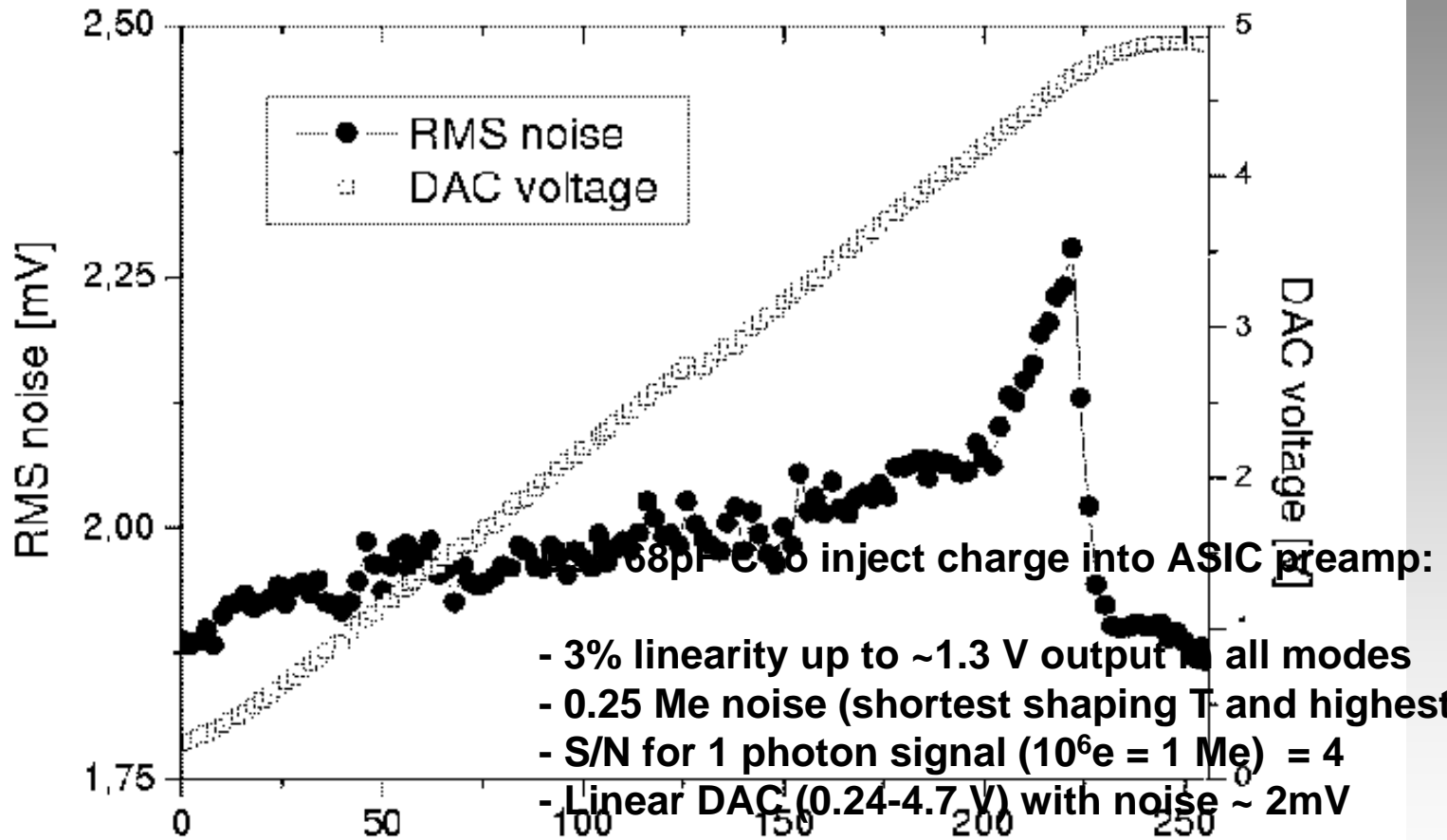


ILC-SIPM



ASIC chip properties

DAC Linearity

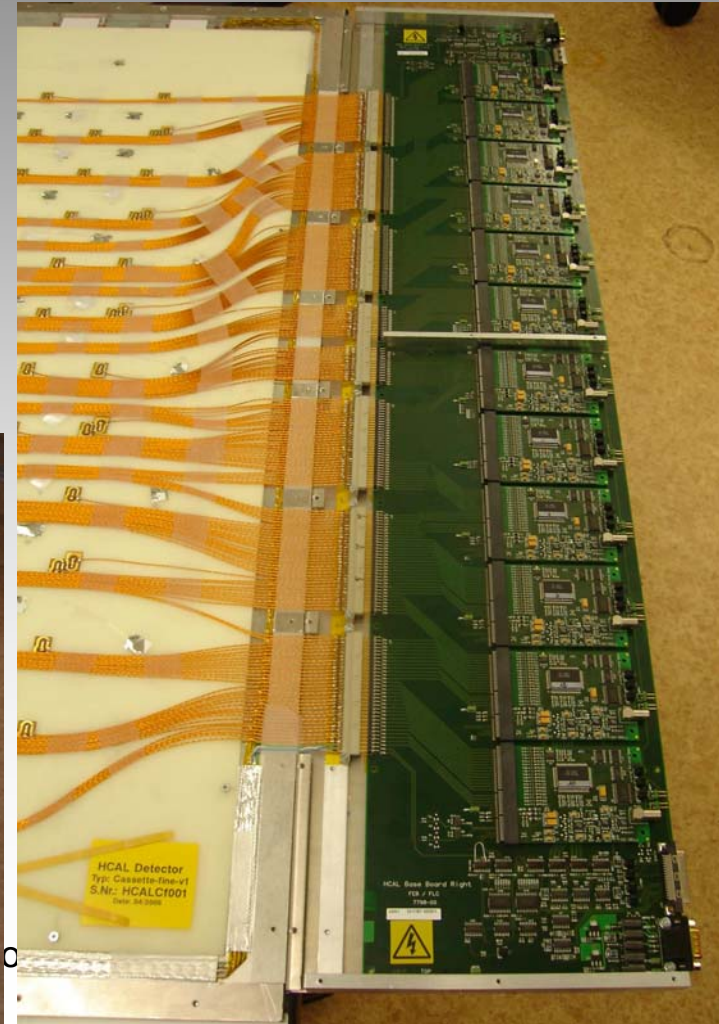
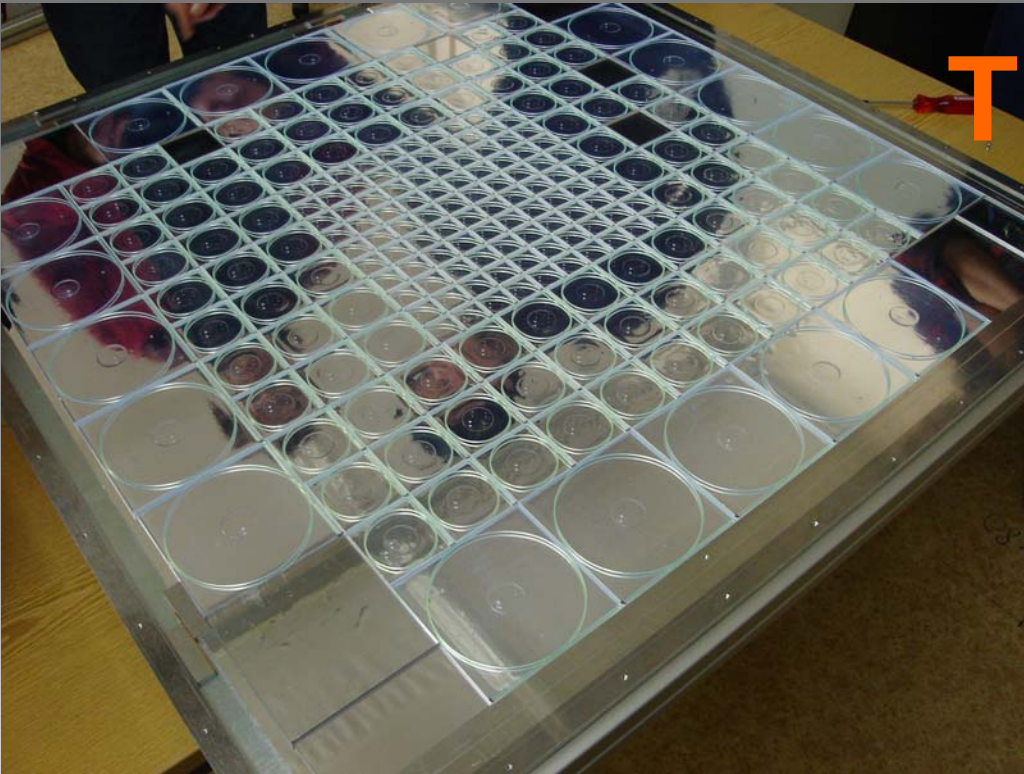


- 0.25 Me noise (shortest shaping T and highest G)
- S/N - Linear DAC (0.24-4.7 V) with noise ~ 2mV
- 3% linearity up to ~1.3 v output in all modes

The first module

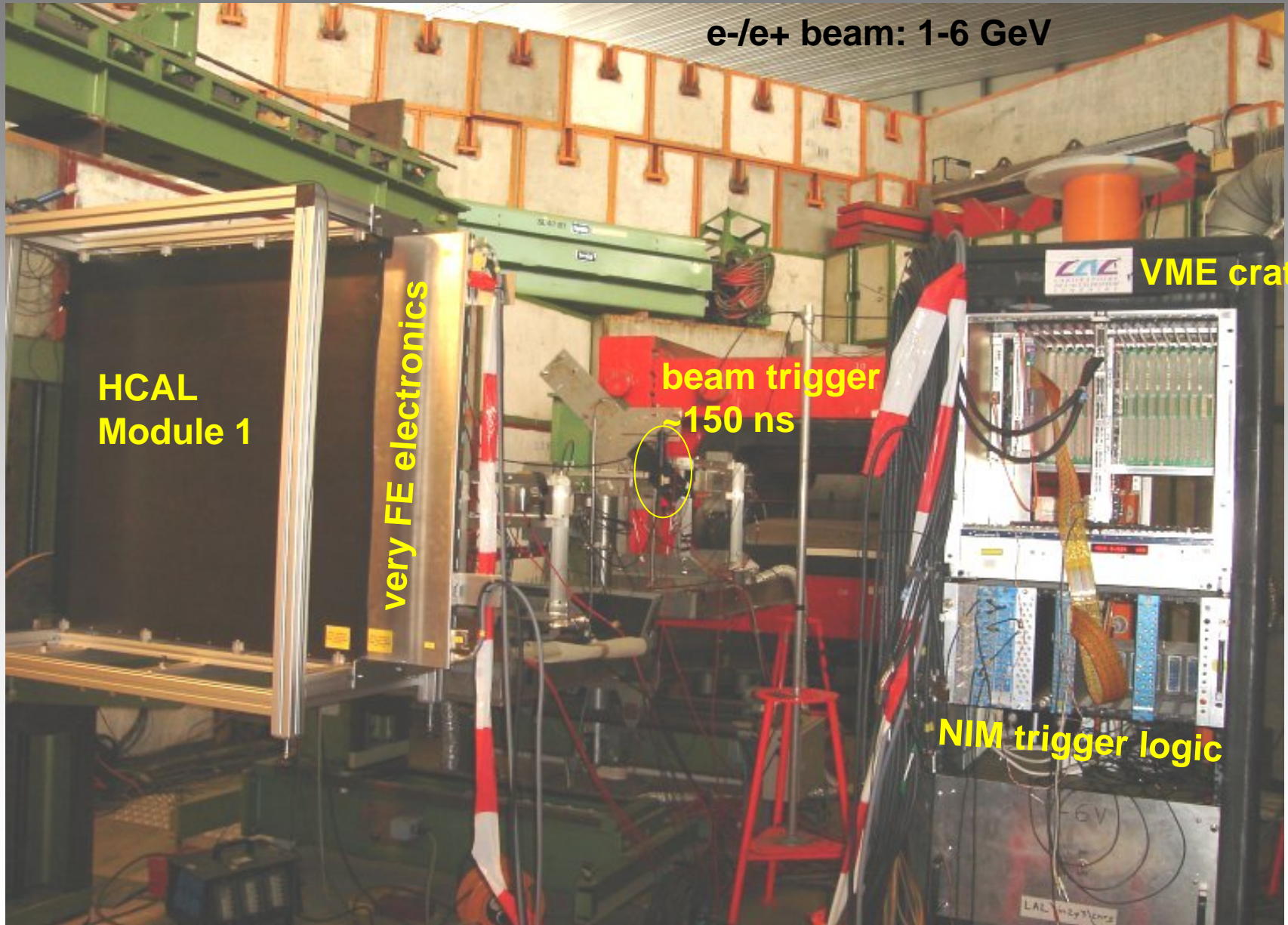
216 tiles with SiPM readout

very front-end electronics



DESY test beam: 1st module test

e-/e+ beam: 1-6 GeV



HCAL
Module 1

very FE electronics

beam trigger
~150 ns

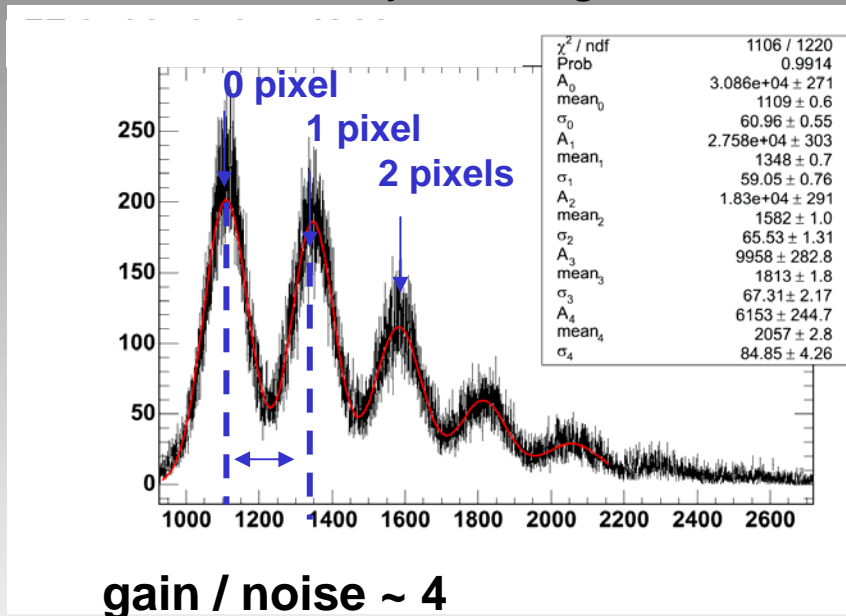
VME crate

NIM trigger logic

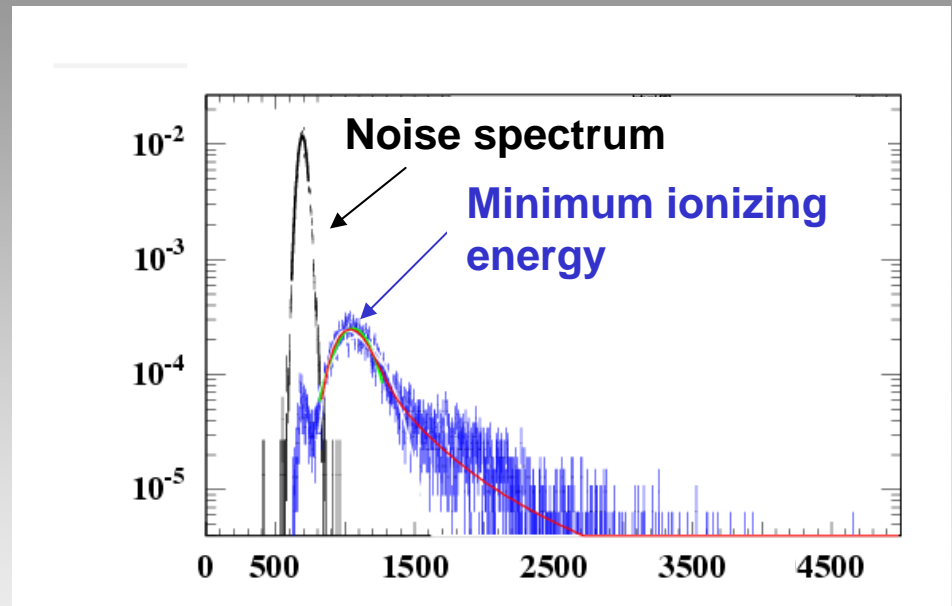
LAL 12/2/1985

Calibration procedure

SiPM **Gain calibration**
with low intensity LED light



MIP calibration of each tile
with 3 GeV e- beam



using ASIC chip in 2 modes:

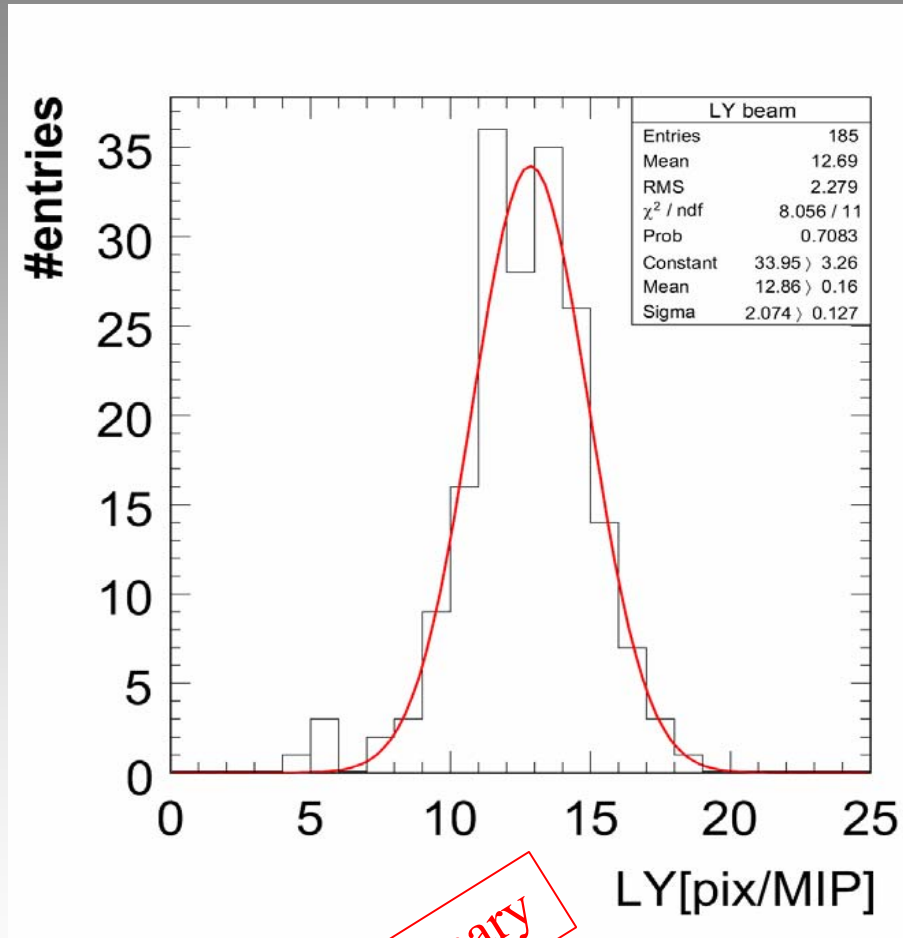
“calibration mode”
short shaping time
highest gain

(40ns)

“physics mode”

longest shaping time (180 ns)
medium gain

LY calibration on module #1



Preliminary

$$LY = \frac{A_{MIP}}{\text{gain}} * \frac{A_{LED}^{calib}}{A_{LED}^{physic}}$$

MIP calibration

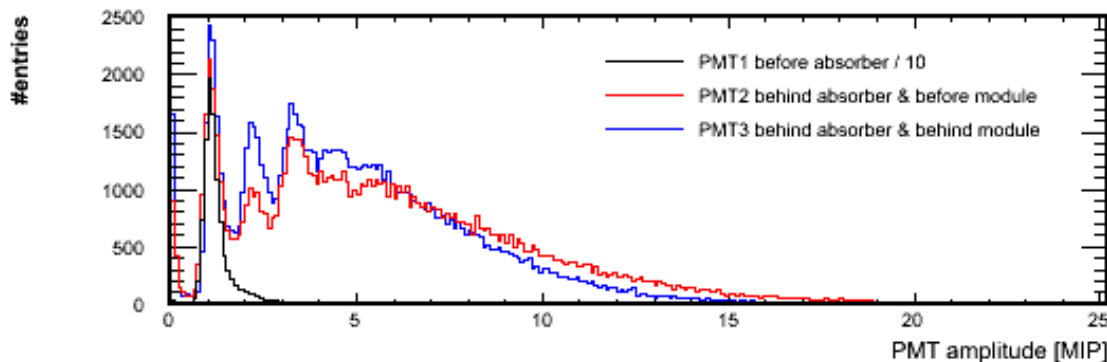
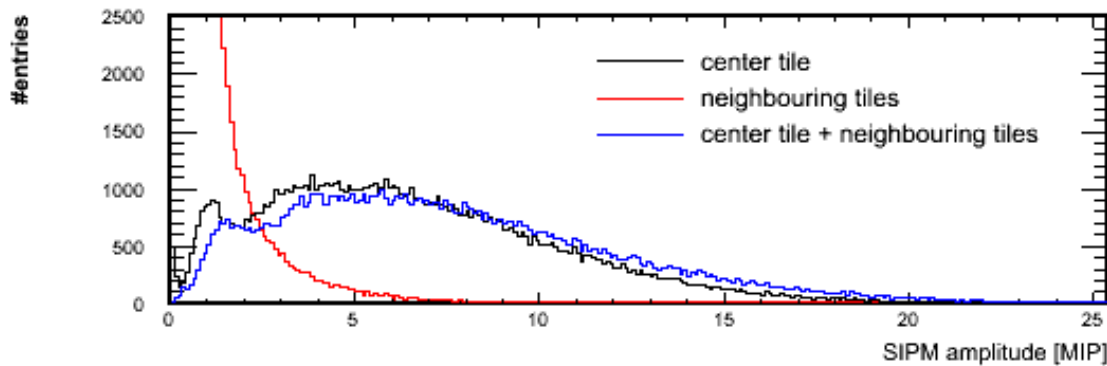
Gain calibration

Intercalibration

Lightyield: 13 ± 2 pix/MIP

LY spread is as expected

Absorber studies on module #1



Analysis ongoing:

- uniformity study
- selection of 1,2,3 MIP signals

➔ better determination of the lower part of the SiPM response function

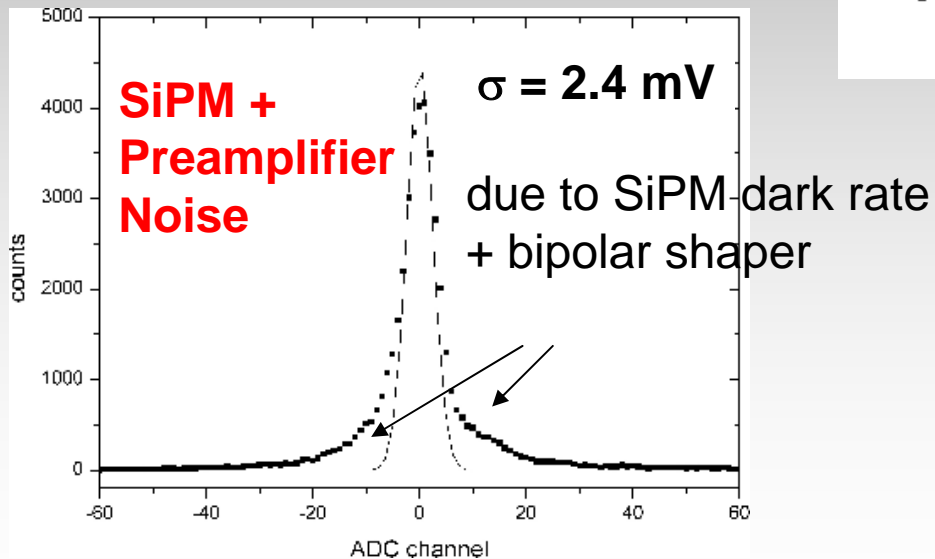
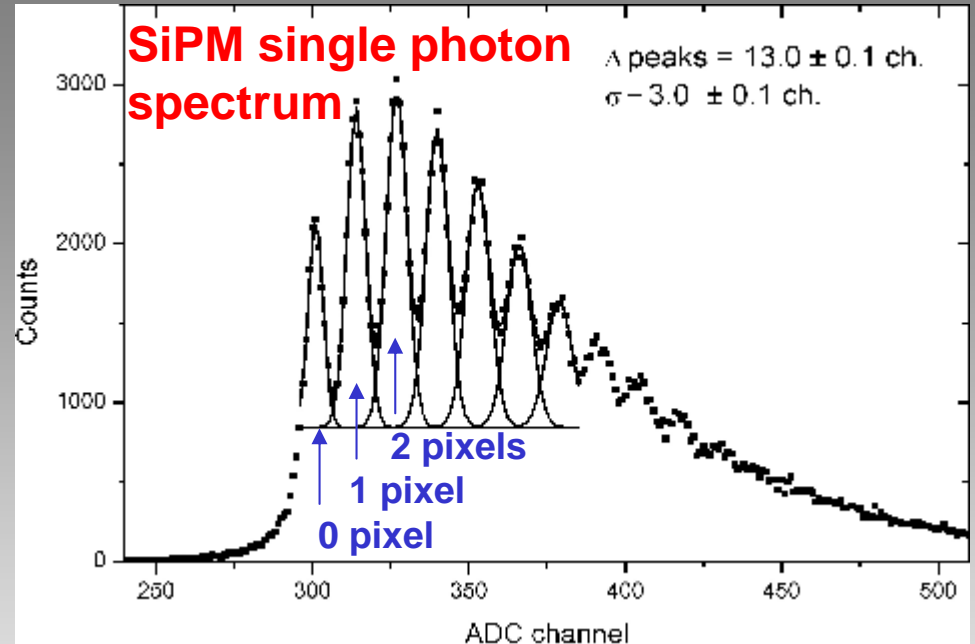
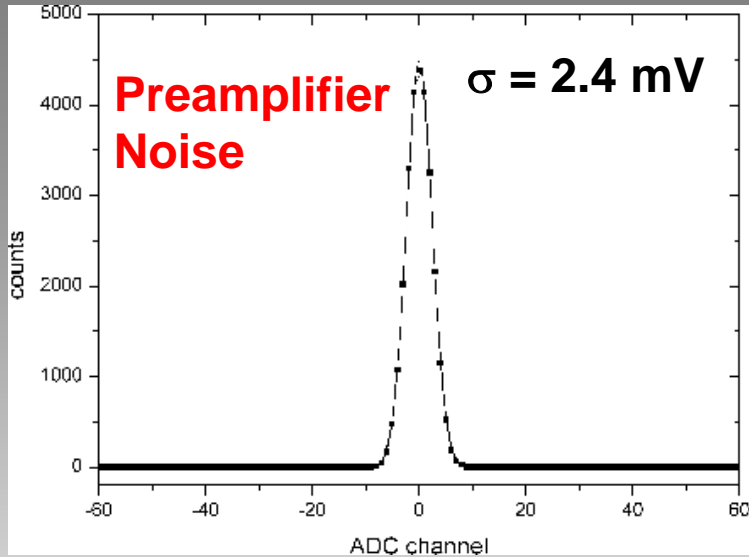
- also 5 X_0 data are available

➔ apply SiPM response function for correction

- We are commissioning a multi-channel system
- The major functionality proof of the front-end electronics is the successful application of the calibration procedure
 - MIP and LY calibration applied to ~200 ch.
 - now to be extended to 8000 ch.
 - integration of the final calibration-monitoring LED system
 - temperature corrections
- High amplitude data are available:
 - test of the correction for the SiPM response function
 - completion of the full calibration chain

BACKUP

SiPM readout with ASIC chip



Use shortest shaping T and highest G for SiPM gain calibration:

- Good separation between peaks
- gain / noise ~ 4 (as expected)

The calibration concept

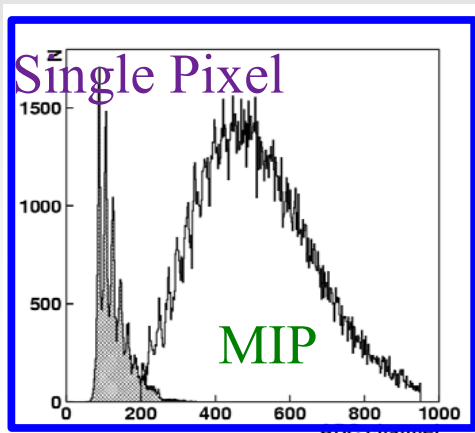
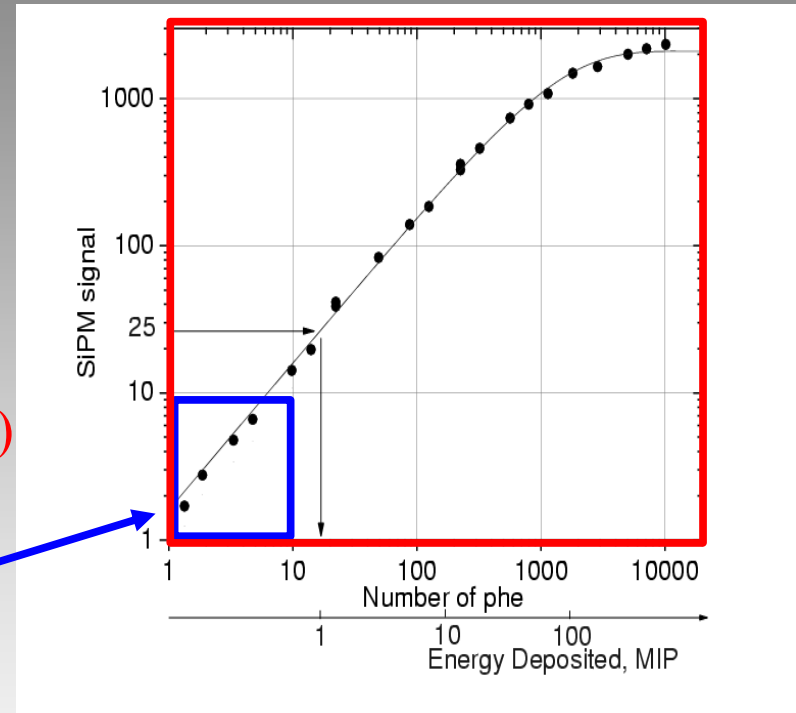
For a calorimeter with linear readout:

$$E = \text{ADC} * \text{MIP}/\text{ADC} * E/\text{MIP}$$

BUT SiPM is nonlinear:

Energy = ADC counts

- * gain (pixel calibration)
- * SiPM response (SiPM response function)
- * light yield (MIP calibration)
- * sampling



$$E = \text{ADC} * \text{pxl}/\text{ADC} * \text{ph.e.}/\text{pxl} * \text{MIP}/\text{ph.e.} * E/\text{MIP}$$